

APPLICANT'S ART CITATION <small>(Use several sheets if necessary)</small>		Application 10/585,289		OFGS File No. P/2850-144		
		Applicant Takeshi Nakamura				
		Filing Date July 7, 2006		Group Art Unit 1755		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-6,838,162 B1	01-2005	GRUBER ET AL.			
	US-2003/0008067 A1	01-2003	YAMAGUCHI ET AL.			
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation Yes No
	CN 1288874	09-2000	CHINA			U.S.P 6,838,162
	JP 2003-20287	01-2003	JAPAN			U.S. PUB. 2003/0008067
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
	Office Action issued November 30, 2007 in corresponding Chinese Application No. 200480039952.9 and an English translation					
Examiner		Date Considered				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						